•	Search Notes	

Application/Control No.	Applicant(s)/Patent under Reexamination
10/565,516	CEDRAEUS, HUGO
Examiner	Art Unit
JOHN J. LEE	2618

SEARCHED						
	JEAR	CUED				
Class	Subclass	Date	Examiner			
455	566 550.1 562.1 63.4 90.1	8/6/2007	J.L			
713	202 201 206					

INT	ERFERENCI	E SEARCH	ED
Class	Subclass	Date	Examiner
- "			

(INCLUDING SEARCH	DATE	EXMR
East Hong Kim (711) Andy Lee (370)	8/6/07	J.L
Hono Kim (711)	8/8/01	すん
Andy Lee (370)	8/8/01	エル
•		
		
,		
		-